



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re the Application of

Shunichi SEKI et al.

Application No.: 10/686,634

Filed: October 17, 2003

Docket No.: 104741.01

For: METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING  
FORMATION OF BANKS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. English-language Abstracts of the non-English language references 1-4 are attached hereto.
- 3. A computer-generated English translation of the following Japanese references has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1-5.

Respectfully submitted,

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Date: June 29, 2004

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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 104741.01	APPLICATION NO. 10/686,634	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT(S) Shunichi SEKI et al.		
				FILING DATE October 17, 2003	GROUP	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	1	JP-A 9-203803 (w/Abst. & trans)	08/1997	JP		
	2	JP-A 9-258208 (w/Abst. & trans)	10/1997	JP		
	3	JP-A 9-230129 (w/Abst. & trans)	09/1997	JP		
	4	JP-A 10-153967 (w/Abst. & trans)	06/1998	JP		
	5	JP-B2 2700316 (w/trans.)	10/1997	JP		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
		K. Imasumi et al., "Injection and Transport of Carriers at Organic Interfaces in Organic Light-Emitting-Diode with Oxadiazole Derivatives," <i>1997 IEEE Annual Report</i> , Conference on Electrical Insulation and Dielectric Phenomena, Minneapolis, October 19-22, 1997, pp. 459-462.				
EXAMINER				DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						